## LAM Beam Analyzer



| Laser Type | CW |
| :--- | :--- |
| Beam width resolution | For beams $>100 \mu \mathrm{~m}$ in size: $1 \mu \mathrm{~m}$. <br> For beams $<100 \mu \mathrm{~m}$ in size: $0.1 \mu \mathrm{~m}$ |
| Beam Size | $35 \mu \mathrm{~m}-\varnothing 8 \mathrm{~mm}$ |
| Spectral Response | Si: $350-1100 \mathrm{~nm}$. Contact factory <br> for other wavelengths |
| Resolution (H x V pixels) | Adaptive according to beam size |
| Sensor Active Area (mm) | $9 \times 9$ |
| Number of Blades | 7 blades with image tomographic <br> reconstruction |
| Gain Control | Automatic |
| Frame Rate | 5 fps |
| Working Distance | 49 mm (contact factory) |
| Maximum BPP | Max. input angle - 25 deg. |
| Maximum power density | $1,000,000$ W/cm ${ }^{2}$ (contact factory) <br> Pelected point |

## Ordering Information

LAM-BA: 7-blades, Si detector with high power attenuator and mounting adapter.

| Power range @900/1070 nm |  <br> pressurized air-cooling, some <br> restrictions may apply) |
| :--- | :--- |
| Output power from back side of <br> beam sampler | With beam dump - no <br> significant output power |
| Cooling conditions | Filtered pressurized air of 6-8 <br> Bar |
| Sensor type | Silicone (Si) <br> technology |
| Beam widte-edge accuracy | $\pm 1.5 \%$ |
| Power accuracy | $\pm 5 \%$ |
| Position resolution | $1 \mu \mathrm{~m}$ |
| Pixel Size | Adaptive according to beam size |
| Pixel Bit Depth | 12 bits |
| Background Subtraction | Automatic |
| Power Requirements | $\sim 2.5$ Watt (Via USB 2.0 <br> interface) |
| Dimensions (L $\mathbf{x} \mathbf{~ W ~} \mathbf{~ H}$ ) in mm | $147 \times 105 \times 48$ |
| Weight (typical) | Sensor head with cable ~ 1500 <br> gr. |
| Min. Hardware Requirements | CPU i3 1.6 GHz, 4 GB RAM |
| Interface |  <br> 64 bit) |
| Operating Temperature | $0^{\circ}-35^{\circ} \mathrm{C}$ |

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## DUMA OPTRONICS LTD.

